033082M251

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Takehiko Fujita, et al.

International Application No.: PCT/JP2003/13849

International Filing Date: October 29, 2003

U.S. Serial No.: To Be Assigned

Group Art Unit: To Be Assigned

Filed: : Herewith

Examiner: To Be Assigned

For: THERMAL PROCESSING UNIT AND THERMAL PROCESSING METHOD

PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to or concurrent with calculation of the filing fees, please amend this application as follows.